

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Shunpei Yamazaki et al      Art Unit : 2825  
Serial No. : 09/894,950      Examiner : Caridad Everhart  
Filed : June 27, 2001      Confirmation No.: 6263  
Title : SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

**MAIL STOP RCE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT**

Applicants request consideration of the references listed on the attached PTO-1449 form. Under 37 C.F.R. § 1.98 (a)(2)(ii), only copies of foreign patent documents and/or non-patent literature are enclosed. A copy of the listed U.S. patent can be provided upon request.

Submitted herewith is an English translation of the following foreign language references, or portions thereof:

Desig. ID	Source
AL	JAPAN 11-087726 – English Abstract: DIALOG(R)File 347:JAPIO (2005); Accession No. 06146186
AM	JAPAN 10-031235 – English Abstract: DIALOG(R)File 347:JAPIO (2005); Accession No. 05748135 and family to U.S. Patent No. 5,966,193 (Desig. ID “AA”)

The Japanese Patent Office is contending that paragraph [0054] of Japan 11-087726 is of particular relevance. An English language translation is being prepared, and will be submitted for consideration in a supplemental information disclosure statement.

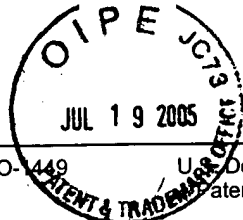
This filing is being made with the filing of a Request for Continued Examination. No fee is required.

Respectfully submitted,

John F. Hayden  
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Date: July 19, 2005

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Substitute Form PTO-1449 (Modified)  <b>Information Disclosure Statement by Applicant</b> (Use several sheets if necessary)  (37 CFR §1.98(b))	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 07977-280001	Application No. 09/894,950
	Applicant Shunpei Yamazaki et al		
	Filing Date June 27, 2001	Group Art Unit 2825	

**U.S. Patent Documents**

Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	5,966,193	10/12/1999	Zhang et al.			07/11/1997
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

**Foreign Patent Documents or Published Foreign Patent Applications**

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AL	11-087726	03/30/1999	JAPAN			AB	
	AM	10-031235	02/03/1998	JAPAN			AB	
	AN							
	AO							
	AP							

**Other Documents (include Author, Title, Date, and Place of Publication)**

Examiner Initial	Desig. ID	Document
	AQ	
	AR	
	AS	
	AT	

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	